



ON THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/810,387  
Confirmation No. .... 8779  
Filing Date ..... March 15, 2001  
Inventor..... Craig M. Carpenter  
Assignee..... Micron Technology, Inc.  
Group Art Unit..... 1763  
Examiner ..... R. Zervigon  
Attorney's Docket No. .... MI22-1559  
Customer No. .... 021567  
Title: Chemical Vapor Deposition Apparatuses and Deposition Methods

**RESPONSE TO DECEMBER 21, 2004 OFFICE ACTION**

To: MS AMENDMENT  
Commissioner for Patents  
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**AMENDMENTS**

04/25/2005 JBALINAN 00000079 09810387

02 FC:1201 200.00 0P  
03 FC:1202 50.00 0P

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